

Filed Via Express Mail pursuant to 37 C.F.R. 101.0

Rec. No.: EV 332 277 014 US

On: OCTOBER 1, 2003

By

LINDA E. HASTINGS

Any fee due as a result of this paper, not covered by an enclosed check, may be charged on Deposit Acct. No. 50-1290.

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YReligion
10/9/03

Attorney Docket No.: NECF 18.591

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: Takaaki NAGAI

Serial No.: 09/837,734

Filed: April 17, 2001

Title: **NON-VOLATILE SEMICONDUCTOR STORAGE
APPARATUS AND MANUFACTURING METHOD THEREOF**

Examiner: Douglas W. Owens

Group Art Unit: 2811

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

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PETITION FOR EXTENSION OF TIME

S I R :

Applicant requests that the time for taking action in this case be extended pursuant to 37 CFR 1.136(a) for:

☐ one month

☐ three months

☒ two months

☐ four months

The fee set in 37 CFR 1.17 for the extension of time is \$420.00.

10/06/2003 AWONDAF1 00000051 501290 09837734

02 FC:1252 420.00 DA

☐ Fee enclosed. Please charge any additional fee required for this extension of time to Deposit Account No. 50-1290. A duplicate copy of this paper is enclosed.

☒ **Charge fee to Deposit Account No. 50-1290. A duplicate copy of this paper is enclosed.**

☐ Applicant is a small entity entitled to pay reduced fees in this application. A verified small entity statement:

☐ has been filed

☐ is enclosed

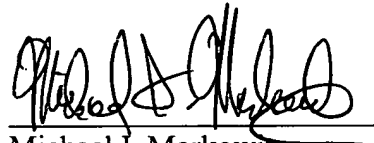
Also enclosed is a:

☒ **Response to Official Action**

☐ Notice of Appeal

☐ Appeal Brief

Respectfully submitted,



Michael I. Markowitz
Reg. No. 30,659

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